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Response Under 37 C.F.R. § 1.116
Expedited Procedure Requested
Examining Group 2823



PATENT
Customer No. 22,852
Attorney Docket No. 04329.2622

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
Gaku MINAMIHABA, et al.) Group Art Unit: 2823
Serial No.: 09/932,943) Examiner: Lee, Hsien Ming
Filed: August 21, 2001)
For: SLURRY FOR CHEMICAL)
MECHANICAL POLISHING AND)
METHOD OF MANUFACTURING)
SEMICONDUCTOR DEVICE)

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

AMENDMENT AFTER FINAL

In reply to the Final Office Action of April 25, 2003, with a period for response
extending through July 25, 2003, Applicants propose amending the application as follows.
Applicants also respectfully request the Examiner's reconsideration in view of remarks that
follow:

IN THE CLAIMS:

Please amend claims 18 and 23, as follows:

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